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GEMOLOGICAL
INSTITUTE

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LABORATORY GROWN DIAMOND REPORT

August 7, 2026

IGI Report Number

LG826615821

Description

LABORATORY GROWN DIAMOND

Shape and Cutting Style

ROUND BRILLIANT

Measurements

8.86 - 8.92 X 5.41 MM

GRADING RESULTS

Carat Weight

2.68 CARATS

Color Grade

F

Clarity Grade

VVS 2

Cut Grade

EXCELLENT

ADDITIONAL GRADING INFORMATION

Polish

EXCELLENT

Symmetry

EXCELLENT

Fluorescence

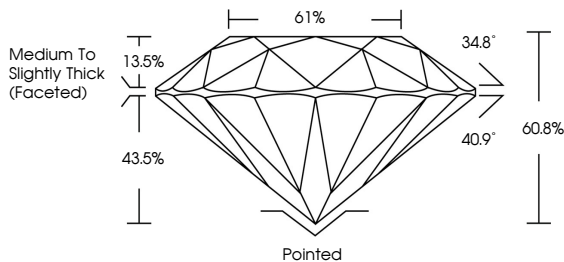
NONE

Inscription(s)

 LG826615821

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

PROPORTIONS



Medium To Slightly Thick (Faceted)

61%

34.8°

40.9°

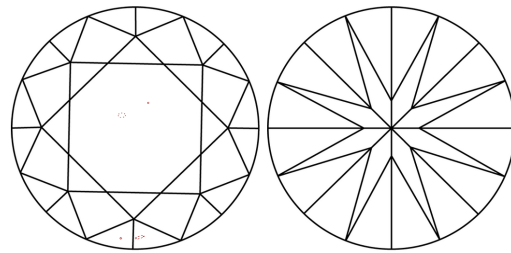
60.8%

43.5%

13.5%

Pointed

CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.

Green symbols indicate external characteristics.

COLOR

D

E

F

G

H

I

J

Faint

Very Light

Light

CLARITY

FL

IF

VVS¹⁻²

VS¹⁻²

SI¹⁻²

I¹⁻³

Flawless

Internally Flawless

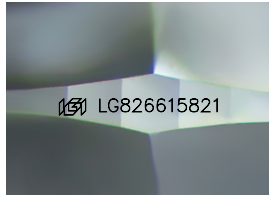
Very Very Slightly Included

Very Slightly Included

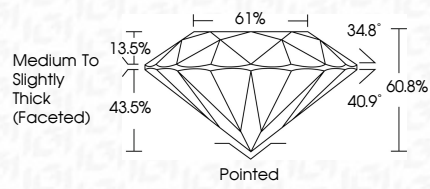
Slightly Included

Included

Sample Image Used



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